

Whyte Hirschboeck Dudek S.C.

FAX COVER SHEET

January 10, 2006

TO:

COMPANY:

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Examiner Pham

USPTO

571-273-1696

FROM:

PAGES:

CLIENT-MATTER:

Kristine M. Strodthoff

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Message:

In re Application of :

Weimer, Ronald A.

Serial No.

09/941,827

Filing Date

August 29, 2001

For

Method of Improved High K Dielectric-Polysilicon Interface for CMOS

Devices

Examiner

HUYNH, Yennhu B.

Group Art Unit

2813

Confirmation No.

7551

Per your request attached is the IDS dated September 4, 2003. Please call me if you have any questions at 414-978-5531.

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Thank you for your cooperation.

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Attorney Docket No. MTI-31532

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Weimer, Ronald A.

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Examiner

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CERTIFICATION UNDER 37 CFR 1.8(a) and 1.10

I hereby certify that, on the date shown below, this correspondence is being

<u>Mailing</u>

 deposited with the United States Postal Service in an envelope addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231

37 CFR 1.8(a)

with sufficient postage as first class mail

37 CFR 1.10

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<u>Transmission</u> addressed to Examiner

U transmitted by facsimile to Fax No___

at the U.S. Patent and Trademark Office.

Date: 17-3-07

Assistant Commissioner for Patents

Washington, D.C. 20231

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with Applicant's duty of disclosure as set forth in 37 C.F.R. §1.56, listed on the attached equivalent to Form PTO-1449 are those patents and other publications known to Applicant which may be considered material to the patentability of the claims of the above-identified application.

Applicant respectfully requests that the listed documents be considered by the Examiner, that these references be made of record in the present application, and that an initialed copy of the Form PTO-1449 be returned to the undersigned in accordance with MPEP 609.

MKE/808000.1

USSN 09/941,827

Supplemental Inf

tion Disclosure Statement

No fee is due for consideration of these items because this statement is submitted prior to the issuance of an Office Action on the merits.

Respectfully submitted,

Dated: December 3,2002

Kristine M. Strodthoff, Reg. No. 34,259

WHYTE HIRSCHBOECK DUDEK S.C. 111 East Wisconsin Avenue, Suite 2100 Milwaukee, Wisconsin 53202 (414) 273-2100

Customer No. 31870

Attorney Docket No. MTI-31532 Patent Serial No. ATTY. DOCKET NO. U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE 09/941,827 MTI-31532 Washington, D.C. 20231 Confirmation No. Applicant INFORMATION DISCLOSURE 7551 Weimer, Ronald A. STATEMENT BY APPLICANT Group Art Unit Filing Date 2812 August 29, 2001

U.S. PATENT DOCUMENTS

Page Nombor	Issue Date	Patentee	U.Ş. Çlass	Sub- Class	Filing Date _
Patent Number 6,475,883	11/05/02	Powell et al.	438	486	07/03/01
 6,410,968	06/25/02	Powell et al.	257	412	08/31/00
 6,362,086	03/26/02	Weimer et al.	438	591	09/15/99
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FOREIGN PATENT OR PUBLISHED FOREIGN PATENT APPLICATION

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Examiner	Document	Publication	}	Int'l	Sub-	Translation
Initial	Number	Date	Country	Class	Class	(Yes/No)_
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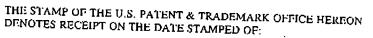
OTHER DOCUMENTS (Including Author, Title, Date, Relevant Pages, Place of Publication)

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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609, Diagrams in the initial in conformance and not considered. Include copy of this form with next communication to applicant.

MKE/808015.1



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Scrial No.:

09/941,827

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7551 2813

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Interface for CMOS Devices

Huynh, Yennhu B.

Examiner; Attorney Docket No.:

MTI-31532

Enclosures: Response, copy of previously submitted IDS and Form 1449/PTO. and return postcard.

Date: September 4, 2003

Express Mail No. EV 326236245 US

PRR/KXS